

14202 U.S. PTO
021804

Page 1

PATENT

Docket No.: JCLA12973

Date: February 18, 2004

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

ATTENTION: APPLICATION BRANCH

Sir:

Transmitted herewith for filing under 37 C.F.R. 1.53(b) is the patent application of

Inventor(s): JACK LIN ;

CALVIN WU ;

GEORGE KC HUANG ;

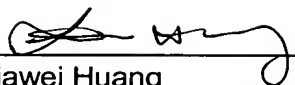
For: **METHOD AND APPARATUS FOR FORMING PATTERNED PHOTORESIST
LAYER**

Enclosed are:

- (X) Specification in SIXTEEN (16) pages.
- (X) FOUR (4) sheets of drawings.
- (X) Return prepaid postcard.

Note:

THIS APPLICATION IS FILED UNSIGNED AND UNPAID


Jiawei Huang
Registration No. 43,330

Please send communications to:
J.C. Patents
4 Venture, Suite 250
Irvine, California 92618
Tel.: (949) 660-0761
Fax: (949)-660-0809

22859 U.S. PTO
10/782369
021804

J.C. PATENTS
4 VENTURE, SUITE 250
IRVINE, CALIFORNIA 92618
TEL : (949) 660-0761
FAX: (949) 660-0809

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

CERTIFICATE OF MAILING BY "EXPRESS MAIL"

Docket No. : JCLA12973

Inventor(s) : JACK LIN ;
CALVIN WU ;
GEORGE KC HUANG ;

For : METHOD AND APPARATUS FOR FORMING PATTERNED
PHOTORESIST LAYER

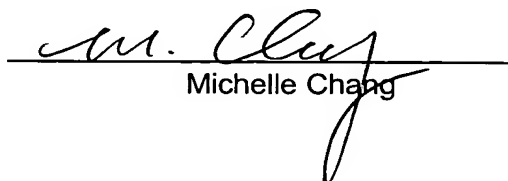
"Express Mail"
Mailing Label No. : EV 301017898 US

Date of Deposit : February 18, 2004

I hereby certify that the accompanying

Transmittal in Duplicate; Specification in 16 page(s); 4 Pages of
Drawings; Return Prepaid Postcard

are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Michelle Chang